THIS TECHNOLOGY IS CURRENTLY NOT AVAILABLE FOR LICENSING

Tech ID: 17860



ADDITIONAL TECHNOLOGIES BY THESE INVENTORS

- Pyroelectric MEMS Infrared Sensor with Numerous Wavelength Absorptions
- Microfluidic Flow Lysometer Device, System And Method
- Microfluidic Reagent Delivery System By Hydrogel Dehydration Through A Porous Encapsulant

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